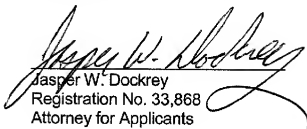


REMARKS

The applicants respectfully request entry of the amendment prior to commencing examination of the application.

Respectfully submitted,


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Amended Abstract

The invention relates to a method of producing a complex microelectronic structure, in which two basic microelectronic structures ~~(1, 3)~~ are assembled at the two respective connecting faces ~~(3)~~ thereof. The invention is characterized in that, before assembly, a difference is created in the tangential stress state between the two faces to be assembled, said difference being selected such as to produce a pre-determined stress state within the assembled structure under given conditions in relations to the assembly conditions.